

Erratum:

Erratum to: A sparse matrix model-based optical proximity correction algorithm with model-based mapping between segments and control sites

Bin LIN[†], Xiao-lang YAN, Zheng SHI, Yi-wei YANG

(Institute of VLSI Design, Zhejiang University, Hangzhou 310027, China)

[†]E-mail: linbin@vlsi.zju.edu.cn

doi:10.1631/jzus.C10e0219

Published online June 12, 2011

Erratum to: *J Zhejiang Univ-Sci C (Comput & Electron)* 2011 12(5):436-442

doi:10.1631/jzus.C1000219

In the online version of the original article, Fig. 11 was incorrect. The correct version is given below.

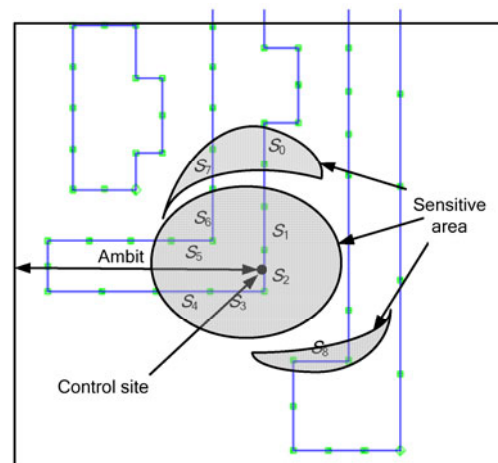


Fig. 11 Segments in the sensitive area playing a major role in changing the intensity of the control site

Only the elements that correspond to the segments in the sensitive areas need to be calculated when evaluating the Jacobian matrix